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Number of Pages (including this page)

Date: April 28, 2004

To: Zoila E. Cabrera - 2125

Location: United States Patent and Trademark Office

Fax No.: (703) 872-9306

From: Joanna G. Chiu - 43,629

Subject: 09/729,636- Karl E. Mautz et al.

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MESSAGE:

Enclosed herewith, please find a FORMAL AMENDMENT for filing in the below-identified application. If Applicant has overlooked any fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit 503079, Freescale Semiconductor, Inc.

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1.	x	1 page Facsimile Cover Sheet
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PLEASE GIVE THESE PAPERS TO:

EXAMINER: Zoila E. Cabrera

GROUP ART UNIT: 2125

SERIAL NO.: 09/729,636

FILED: DECEMBER 4, 2000

INVENTOR: KARL E. MAUTZ ET AL.

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APPLICANT(S) Karl E. Mautz et al. GROUP ART UNIT: 2125
APPLN. NO.: 09/729,636 EXAMINER: Zoila E. Cabrera
FILED: December 4, 2000
TITLE: ASSEMBLY COMPRISING A PLURALITY OF MASK CONTAINERS
AMNUFACTURING SYSTEM FOR MANUFACTURING
SEMICONDUCTOR DEVICES AND METHOD

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Pat Thomas
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RESPONSE TO REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated January 29, 2004, and Examiner's comments with
regard thereto, please enter the following amendments in the above-entitled application, without
prejudice or disclaimer.